

07/10/01
JC992 U.S. PTO

07-11-01

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Atty. Docket No. AMAT/4180/PDD/KPU/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Box Patent Application
Assistant Commissioner of Patents and Trademarks
Washington, D.C. 20231

09/902518
JC997 U.S. PTO
07/10/01

Re: Inventor(s): Kegang Huang; Judy H. Huang; and Ping Xu
Title: Method and Apparatus for Treating Low K Dielectric Layers to Reduce Diffusion

Transmitted herewith is the patent application identified above, including:

Specification, claims and abstract, totaling 24 pages.
 Drawings totaling 5 pages, 6 Formal Informal.
 Declaration and Power of Attorney (Unsigned).
 Information Disclosure Statement w/ Form 1449 and References.
 Assignment of the invention to **Applied Materials, Inc.**

Assignment Recordation Cover Sheet

FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	31	-20=	11	x \$18.00	-- \$ 198.00
Independent Claims	3	-3=	0	x \$80.00	-- \$ 0.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$ 908.00

The Commissioner is hereby authorized to charge \$908.00 to Deposit Account No. AMAT/4180/PDD/KPU/JW.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. AMAT/4180/PDD/KPU/JW. A duplicate copy of this transmittal is enclosed.

Please address all future correspondence to:

**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

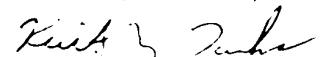
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No: EL 849164749 US.

Date of Deposit: July 10, 2001

Signature: Kurt M. Tackett

Respectfully submitted,


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